

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Han et al.	Group Art Unit: 1775
Application No: 10/824,123	Examiner: Michael E. Lavilla
Confirmation No: 6448	Attorney Docket No:
Filed: April 13, 2004	003330 P01 USA/ETCH/METAL/MD
Title: PROCESS CHAMBER COMPONENT HAVING ELECTROPLATED YTTRIUM CONTAINING COATING	December 7, 2007 San Francisco, California

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

VIA ELECTRONIC FILING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner Lavilla:

This communication is in response to the Office Communication mailed on September 7th, 2007, and is being filed with a petition for a one-month extension of time.